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COPY

NISSIN ION EQUIPMENT CO., LTD.

29 HINOKIGAOKA, MINAKUCHI-CHO, KOKA-CITY, SHIGA, 528-0068, JAPAN

This is a multi-site certificate, additional site(s) are listed on the next page(s)

*Bureau Veritas Certification Holding SAS - UK Branch certifies that the Management System of the above organisation has been audited and found to be in accordance with the requirements of the management system standards detailed below*

## ISO 9001:2015

Scope of certification

- DESIGN, DEVELOPMENT AND MANUFACTURE OF
  - (1) ION IMPLANTER FOR SEMICONDUCTOR MANUFACTURING
  - (2) ION IMPLANTER FOR FPD(Flat Panel Display) MANUFACTURING
- PROVISION OF ION IMPLANTATION SERVICES

Original cycle start date:	11-11-1996
Expiry date of previous cycle:	NA
Certification / Recertification Audit date:	30-11-2023
Certification / Recertification cycle start date:	09-01-2024
Subject to the continued satisfactory operation of the organisation's Management System, this certificate expires on:	16-01-2027

Certificate No.: JP024338

Version: 2

Issue date: 23-12-2024



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**Signed on behalf of BVCH SAS UK Branch**

Certification Body Address: 5th Floor, 100 Lower Thames Street, London, EC3R 6DL, United Kingdom

Bureau Veritas Japan Co., Ltd. Certification Division KRC bldg. 8F, 18 Nihon-odori, Naka-ku, Yokohama, 231-0021, Japan

Further clarifications regarding the scope and validity of this certificate, and the applicability of the management system requirements, please call: 045-651-4784

UKAS Certificate Template Multi Site Rev.4.3

4 Nov 2024





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Scope of certification

Site Name	Site Address	Site Scope
SHIGA PLANT	29 HINOKIGAOKA, MINAKUCHI-CHO, KOKA-CITY, SHIGA, 528-0068, JAPAN	DESIGN, DEVELOPMENT AND MANUFACTURE OF ION IMPLANTER FOR SEMICONDUCTOR MANUFACTURING AND FPD(Flat Panel Display) MANUFACTURING
KUZE PLANT	575 KUZE-TONOSHIRO-CHO, MINAMI-KU, KYOTO-CITY, KYOTO, 601-8205, JAPAN	· DEVELOPMENT OF ION IMPLANTER FOR SEMICONDUCTOR MANUFACTURING · PROVISION OF ION IMPLANTATION SERVICES
KYOTO LOGISTICS CENTER	1 TAKADA, MORIMOTO-CHO, MUKO- CITY, KYOTO, 617-0003, JAPAN	LOGISTICS OF ION IMPLANTER FOR SEMICONDUCTOR MANUFACTURING AND FPD(Flat Panel Display) MANUFACTURING
TOJI OFFICE	4F GRAND KYOTO, 75 NISHIKUJO- HIGASHIHIEIJO-CHO, MINAMI-KU, KYOTO-CITY, KYOTO, 601-8438, JAPAN	SALE OF ION IMPLANTER FOR SEMICONDUCTOR MANUFACTURING AND FPD(Flat Panel Display) MANUFACTURING

Certificate No.: JP024338

Version: 2

Issue date: 23-12-2024



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